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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10023418	FILING DATE 12/17/2001	CLASS 502	SUBCLASS 102.12	GAU 4709	EXAMINER Ver Steeg
<b>**APPLICANTS:</b> Lee Shuit-Tong; Bello Igor; Lee Chun-Sing; Li Quan; Shang Naigui;					
<b>**CONTINUING DATA VERIFIED:</b> SHV none					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> SHV none					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no Verified and Acknowledged Examiner's initials SHV				ATTORNEY DOCKET NO 12364.36US01	
TITLE : Large area silicon cone arrays fabrication and cone based nanostructure modification					

U.S. DEPT. OF COMM./PAT. & TM-PTO-435L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>Application Examiner</b>	
		<b>PREPARED FOR ISSUE</b>	
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